

Docket No.: 1514.1032

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Ji Yong PARK et al.

Application No. 10/690,507

Group Art Unit: 1792

Confirmation No. 6043

Filed: October 23, 2003

Examiner: Matthew J. Song

For: METHOD FOR MANUFACTURING POLYCRYSTALLINE SILICON THIN FILM AND
THIN FILM TRANSISTOR FABRICATED USING POLYCRYSTALLINE SILICON THIN
FILM MANUFACTURED BY THE MANUFACTURING METHOD

RESPONSE IN SUPPORT OF REQUEST FOR CONTINUED EXAMINATION (RCE)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is in response to the Advisory Action dated on March 19, 2008 and the final Office Action mailed November 26, 2007, and having a period for response set to expire on February 26, 2008. The following remarks and Declaration under Rule 312 are respectfully submitted. Reconsideration of the claims is respectfully requested.